

C H A P T E R -VI  
ESTIMATION OF PHYSICAL PARAMETERS OF THE  
PEC CELL FORMED WITH  $WO_3$  PHOTOANODE BY USING  
GARTNER'S MODEL

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CHAPTER-VI  
ESTIMATION OF PHYSICAL PARAMETERS OF THE  
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**6.1 INTRODUCTION :**

Tungsten oxides, unlike tungsten chalcogenides, are less studied materials specifically for its use as a photoanode in photoelectrochemical cells. As, for the semiconducting properties of  $WO_3$ , different values of band gap energy and flat band potentials, have been reported by different authors [1-7]. A large influence on both parameters seems attributable to the different preparation techniques. The variation in band gap energy and flat band potential could be explained by the amorphous or crystalline nature of  $WO_3$ , the presence of surface states and to the different measuring techniques. The density of the surface states as well as its distribution in the energy within the band gap is known to be very sensitive both to the different preparation techniques of the electrodes and to the semiconductor-electrolyte interface [8]. Therefore, it is of interest to estimate these parameters for  $WO_3$  thin films prepared by spray pyrolysis technique.

The physical parameters such as band gap energy ( $E_g$ ) of a semiconductor, concentration of carriers ( $N_D$ ), flat band potential ( $V_{fb}$ ) etc. could be determined by photoelectrochemical technique [9,10]. In fact, Gartner's model

of the metal-electrolyte junction can also provide a successful physical description of the semiconductor-electrolyte interface with both single crystals and polycrystalline electrodes [11]. In this investigation we have used Gartner's model for the estimation of different parameters of PEC cell; formed with sprayed  $\text{WO}_3$  thin film.

## 6.2 EXPERIMENTAL :

The  $\text{WO}_3$  thin films prepared by spraying 0.04 M solution on to F.T.O. coated glass were used for this study. A photoelectrochemical cell was formed using  $\text{WO}_3$  films as a photoanode, 0.1 M  $\text{Na}_2\text{SO}_4$  as an electrolyte and graphite rod as a counter electrode. A saturated calomel electrode (SCE) was used as a reference electrode. The silver paste was applied to ensure ohmic contact with the substrate. A 80 watt mercury vapour lamp was employed to illuminate the cell. Interference filters were used to obtain monochromatic light. The current through the circuit and voltage applied to the cell were measured by (input) nanoameter and digital D.C. voltmeter respectively. The illuminometer model 5200 (Kyoritsu Electrical Instruments Works Ltd., Japan) was used for the intensity measurements.

## 6.3 RESULTS AND DISCUSSION :

The PEC cell was fabricated by employing these films as photoanodes. The cell configuration was as follows,



The cell was then illuminated with filtered light from mercury vapour lamp and photocurrents at different reverse bias voltages were recorded for different wavelengths.

Under the assumptions of Gartner's model and for the case of n-type semiconductor, the photocurrent is given by [4],

$$I_{ph} = -q \phi_0 \left( 1 - \frac{e^{-\alpha W}}{1 + \alpha L_p} \right) \quad \dots\dots(1)$$

where  $\phi_0$  is the photon flux,  $\alpha$  is the absorption coefficient,  $L_p$  is the hole diffusion length,  $q$  is electronic charge and  $W$  the width of depletion layer which is given by,

$$W = W_0 (V - V_{fb})^{1/2} \quad \dots\dots(2)$$

and

$$W_0 = \left( \frac{2 \epsilon \epsilon_0}{q N_D} \right)^{1/2} \quad \dots\dots(3)$$

where  $V_{fb}$  is flat band potential,  $(V - V_{fb})$  is the band bending,  $\epsilon$  and  $\epsilon_0$  are the dielectric constants of semiconductor and the vacuum respectively and  $N_D$  is the donor concentration.

Substituting the value of  $W$  in equation (1) and if  $L_p \ll 1$  and  $\alpha W_0 (V - V_{fb})^{1/2} \ll 1$ , the relation between applied potential and photocurrent becomes,

$$(V - V_{fb}) \approx \left( \frac{I_{ph}}{\alpha W_0 q \phi_0} \right)^2 \quad \dots\dots(4)$$

This equation is used to estimate the value of flat band potential of the PEC cell. A linear relationship between the square of the photocurrent and voltage applied was observed and is shown in Fig.6.1 for two different wavelengths. The

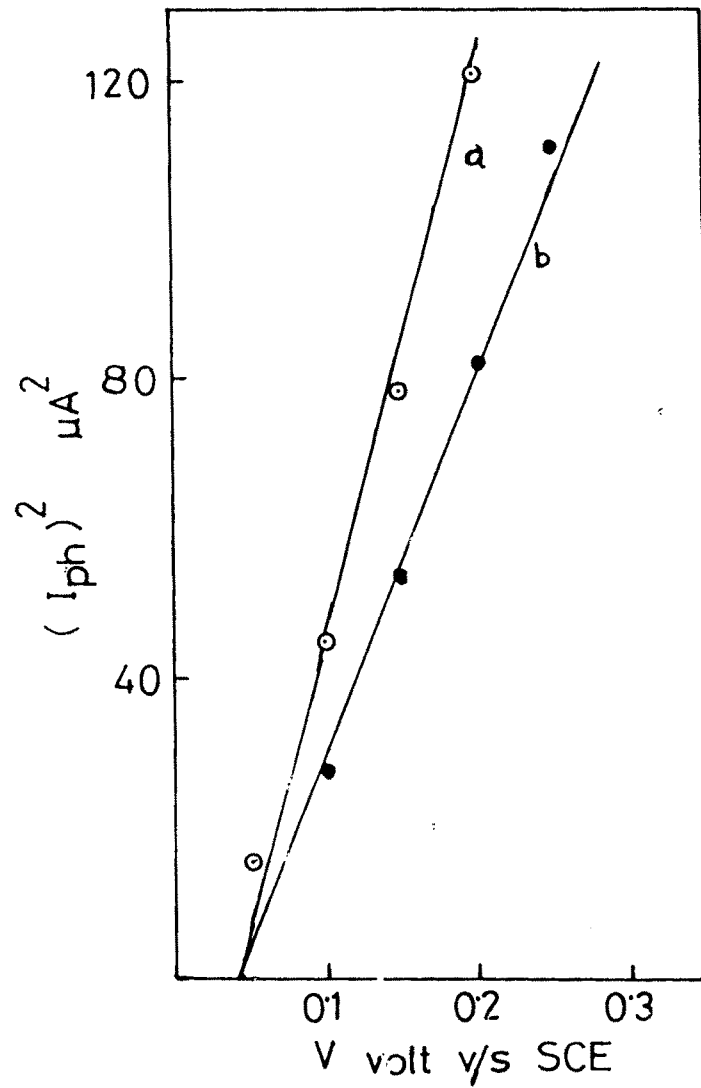


Fig.6.1 : The square of the photocurrent versus applied potential for a  $WO_3$  electrode at (a) 375 nm and (b) 425 nm wavelength of incident light.

value of the flat band potential was obtained by extrapolating the  $I_{ph}^2$  versus  $V$  plot to zero photocurrent [13]. The linear plots obtained in Fig.1 yields the  $V_{fb}$  of 0.04 V versus SCE for two different incident wavelengths viz. 375 and 425 nm. This value of  $V_{fb}$  agrees within 0.1 V with the value of  $V_{fb}$  obtained from Mott-Schottky plots. Similar types of results were obtained by M.A.Butler [4]. He used single crystals of  $WO_3$  grown by vapour transport method and using 1 M sodium acetate as an electrolyte, reported the value of  $V_{fb}$  determined from the photoresponse to be 0.1 V versus SCE, agree within 0.2 V with the value obtained by capacitance measurements using a Mott-Schottky plot. The capacitance in PEC cell system depends strongly on sample history and electrolyte. Thus it can be said that, the photoresponse measurements are more reliable than the capacitance technique which is sensitive to surface states and adsorbed species. The difference in the value of  $V_{fb}$  obtained, in this case and that obtained by M.A.Butler [4], from photoresponse measurements can be attributed to the difference in nature of samples used.

According to Kennedy and Frese [14], Gartner's theory of the Schottky barrier model to the semiconductor electrolyte interface also provides, within some limitations, a direct determination of donor density and the hole diffusion length.

In fact equation (1) leads to equation,

$$\ln(1 - \eta') = -\alpha \left( \frac{2 \epsilon \epsilon_0}{q N_D} \right)^{1/2} (V - V_{fb})^2 - \ln(1 + \alpha L_p) \quad \dots\dots(5)$$

where  $\eta'$  represents the quantum efficiency,

$$\eta' = \frac{I_{ph} \cdot h\nu}{q\Phi_0} = \frac{\text{photocurrent} \times h\nu}{q \cdot \text{Intensity of light}}$$

According to equation (5) plot of  $\ln(1-\eta')$  versus  $(V - V_{fb})^{1/2}$  should be linear with slope equal to  $-\alpha \left(\frac{\epsilon \epsilon_0}{q \cdot N_D}\right)^{1/2}$  and an intercept of  $-\ln(1 + \alpha L_p)$  from which  $N_D$  and  $L_p$  can be obtained. Fig.2 shows plots of  $\ln(1-\eta')$  versus  $(V-V_{fb})^{1/2}$  for light of wavelengths 375 and 425 nm. Using the value of  $\alpha = 2.13 \times 10^4 \text{ cm}^{-1}$  obtained from optical absorption measurements and  $\epsilon = 50$ , the analysis of Fig.6.2 yielded the carrier concentration  $N_D$  to be about  $6 \times 10^{16} \text{ cm}^{-3}$  and hole diffusion lengths were 0.05 and 0.03  $\mu\text{m}$  for incident wavelength 375 and 425 nm respectively. This value of  $N_D$  is one order higher and the values of  $L_p$  are one order less than that reported by others [4,15]. This discrepancy in the observed value of  $L_p$  may be attributed to the different hole mobility factors.

It has been shown that near the band edge  $\alpha$  usually follows the relation [16],

$$\alpha = \frac{A (h\nu - E_g)^n}{h\nu} \quad \dots\dots(6)$$

where A is a constant,  $E_g$  is the band gap and n is related to the nature of the fundamental optical transition ( $n=1/2$  for direct transition and  $n=2$  for indirect transition). Assuming that  $\alpha W \ll 1$  and  $\alpha L_p \ll 1$ , conditions generally fulfilled in PEC's photoelectrodes, equation (1) can be written as,

$$\eta' = \alpha (L_p + W) \quad \dots\dots(7)$$

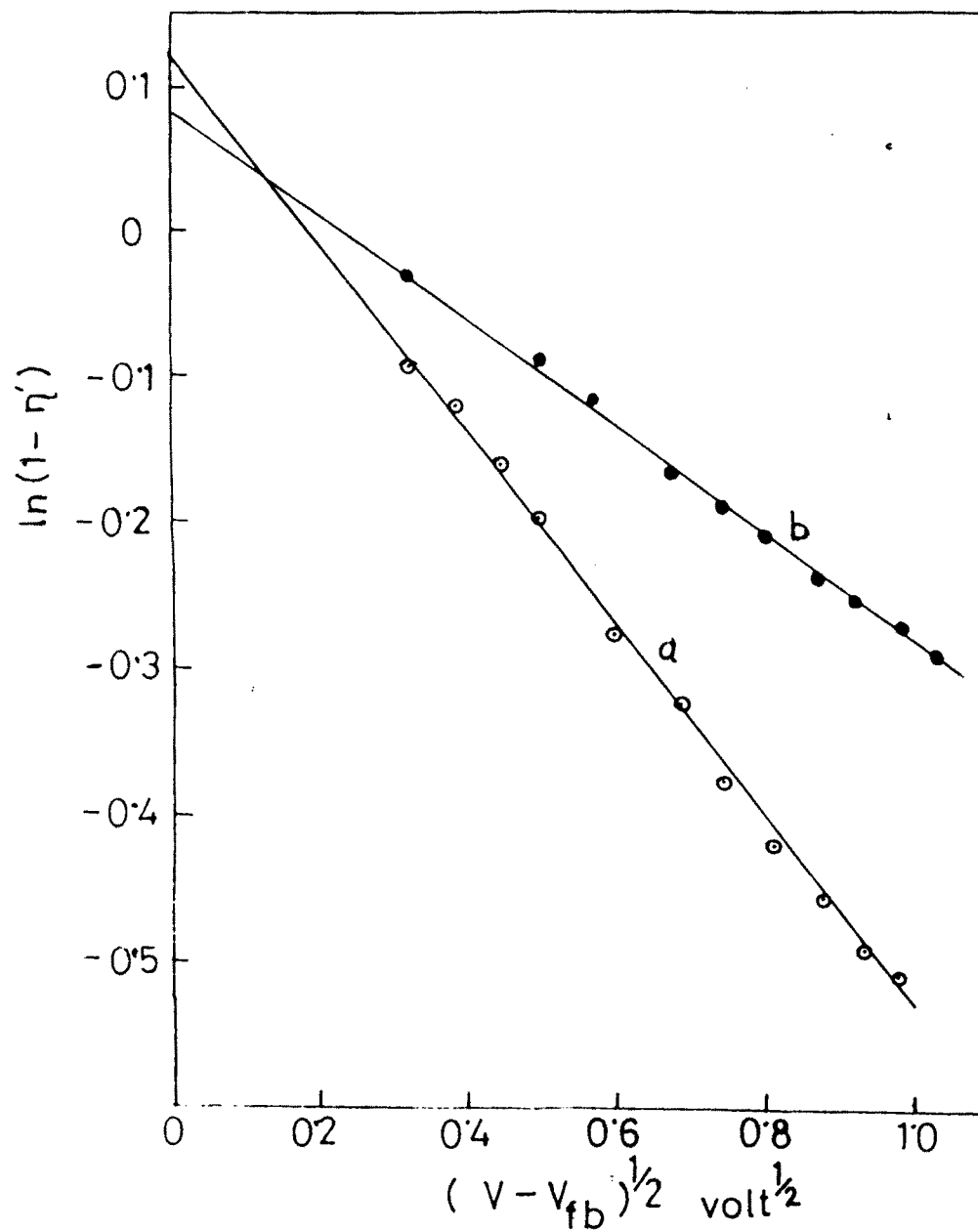


Fig.6.2 : Plot of  $\ln(1-\eta')$  versus  $(V-V_{fb})^{1/2}$  for (a) 375 nm and (b) 425 nm wavelength of incident light.



optical absorption studies for the material showed that the material of film is showing direct optical transition.

From the equation (5) and (6), for the direct band gap semiconductors one obtains,

$$(\eta' h\nu)^2 = (L_p + W)^2 A^2 (h\nu - E_g)$$

Therefore, linear plot of  $(\eta' h\nu)^2$  versus  $h\nu$  allows  $E_g$  to be obtained.

From the survey of literature it is found that the  $E_g$  of  $WO_3$  thin film semiconductor varies in the range 2.5 to 3.2 eV depending on sample history and preparation techniques [1-4,6,7].

Fig.6.3 shows the plot of  $(\eta' h\nu)^2$  versus  $h\nu$  and extrapolation of the linear portion leads to value of 2.9 eV. The value of  $E_g$  obtained from optical absorption study was 2.54 eV. For optical absorption study only  $WO_3$  thin film was scanned while in this case  $WO_3$  thin film dipped in  $Na_2SO_4$  electrolyte was used. The difference in the obtained values of bandgap may arise because of the presence of built-in potential across the semiconductor-electrolyte interface.

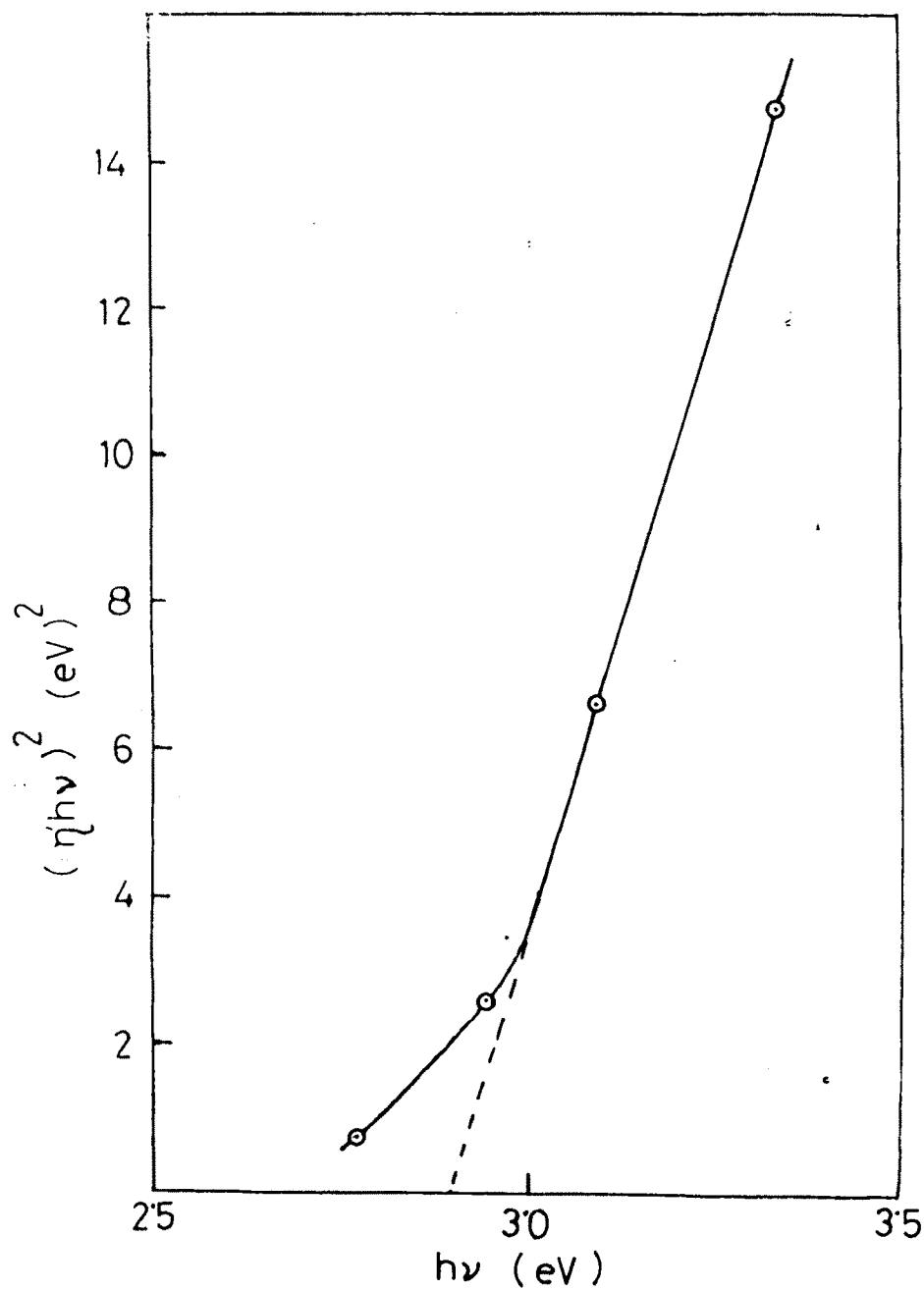


Fig. 6.3 : The plot of variation of quantum efficiency with photon energy for 0.2 volt applied potential to the  $\text{WO}_3$  electrode.

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